

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L3	5570	(118/715).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/02 16:56
L4	51	L3 and ((thermal\$3 decompos\$4) same powder or dust) and \$10silane	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L5	296	L3 and ((thermal\$3 decompos\$4) same powder or dust)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L6	5570	(118/715).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/02 16:56
L7	15	L6 and (collect same (powder or dust))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L8	35	L6 and (collect same (product))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L9	82	L6 and (collect\$3 same (product))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L10	1928	deposit same (polycrystalline silicon)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56

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L11	56	L10 same particle	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L12	202	deposit same (polycrystalline silicon) same (silicon substrate)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L13	186	deposit same (polycrystalline silicon) and ((silicon or Si) with (holder or support or susceptor))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L14	2236	((silicon or Si) adj3 (holder or support or susceptor)) and (CVD or chemical vapor deposition)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L15	476	L14 and (tube or cylinder)	USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2006/11/02 16:56
L16	20	(L4 L5 L7 L8 L9 L11 L12 L13 L15) and (@pd>="20060610") and (@rlad<="20030917" or @ad<="20030917")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/02 16:58